

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Dureseti CHIDAMBARRAO, et al. Group Art Unit: 2814
 Appln. No. : 10/605,108 Examiner: PHAM, Long
 Filed : September 9, 2003
 For : METHOD FOR REDUCED N+ DIFFUSION IN STRAINED SI
 ON SI/GE SUBSTRATE

CHANGE OF CORRESPONDENCE ADDRESS

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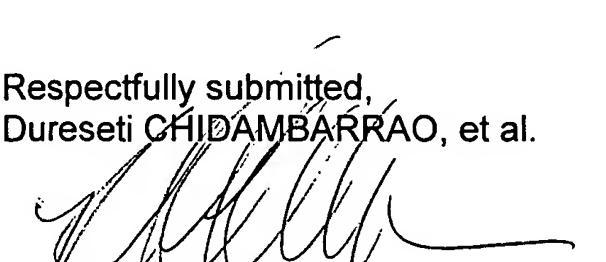
Sir:

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Should there be any questions or comments, the Examiner is invited to contact the undersigned at the below listed telephone number.

Respectfully submitted,
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October 13, 2005
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